



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
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Title of
Invention

SYSTEM, APPARATUS AND METHOD FOR
CONTAMINANT REDUCTION IN SEMICONDUCTOR
DEVICE FABRICATION EQUIPMENT COMPONENTS

Application Number: 10/801435



Confirmation Number: 3084

First Named Applicant: Darwin Enicks

Attorney Docket Number: ATM-277

Art Unit: 1724

Search string: (3888518 or 4352532 or 4437479 or 4852516
or 5449294 or 5453124 or 5881476 or 5992463
or 6099599 or 6199255 or 6325886 or 6349744
or 6442867 or 6598279 or 6607605).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
KL	1	3888518	1975-06-10	Delessert	A1	285	39
	2	4352532	1982-10-05	Hardin	A1	339	15
	3	4437479	1984-03-20	Bardina et al.	A1	134	68
	4	4852516	1989-08-01	Rubin et al.	A1	118	715
	5	5449294	1995-09-12	Rench et al.	A1	437	225
	6	5453124	1995-09-26	Moslehi et al.	A1	118	715
	7	5881476	1999-03-16	Strobush et al.	A1	34	451
	8	5992463	1999-11-30	Redemann et al.	A1	137	884
	9	6099599	2000-08-08	Wu	A1	29	25.01
	10	6199255	2001-03-13	Wang et al.	A1	29	239
	11	6325886	2001-12-04	Harris et al.	A1	156	314
	12	6349744	2002-02-26	Grosshart	A1	137	884
	13	6442867	2002-09-03	Pressnall et al.	A1	34	410
✓	14	6598279	2003-07-29	Morgan	A1	29	402.08
KL	15	6607605	2003-08-19	Tan	A1	134	3

Signature

Examiner Name	Date
<i>Kevin Lee</i>	<i>12/8/05</i>